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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Mu Jen Lai :
Serial No. : 10/603,864 : Art Unit #1765
Filed : 26 June 2003 : Examiner: F. C. Hiteshew
Title : AN EPITAXIAL STRUCTURE :
AND PROCESS OF GAN BASED
COMPOUND SEMICONDUCTOR

RESPONSE TO RESTRICTION REQUIREMENT
AND AMENDMENT

Mail Stop NO FEE
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant, by the undersigned attorney hereby responds to the outstanding
Official Action dated 24 January 2005 which is a Restriction Requirement. Please
amend the above-referenced patent application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.